

## Electronic Acknowledgement Receipt

EFS ID:	1183423
Application Number:	10750983
Confirmation Number:	5470
Title of Invention:	Semiconductor device having silicide layers and method of fabricating the same
First Named Inventor:	Jeong-Min Choi
Customer Number:	20575
Filer:	Hosoon Lee/Stormi Davis
Filer Authorized By:	Hosoon Lee
Attorney Docket Number:	4591-366
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Submitted with Payment	no
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### File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Response to Election / Restriction Filed	RR.pdf	48918	no	1

Warnings:		
Information:		
<table><tr><td><b>Total Files Size (in bytes):</b></td><td>48918</td></tr></table>	<b>Total Files Size (in bytes):</b>	48918
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<p><b>New Applications Under 35 U.S.C. 111</b> If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.</p>		
<p><b>National Stage of an International Application under 35 U.S.C. 371</b> If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.</p>		